

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroji AGA et al.

Application No.: New U.S. National Stage of PCT/JP03/09007

Filed: January 26, 2005

Docket No.: 121797

For: METHOD OF FABRICATING SOI WAFER

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

**Amendments to the Claims** as reflected in the listing of claims;

**Amendments to the Drawings** include an attached replacement sheet;

**Remarks.**